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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :
YASUTAKA ITO ET AL : ATTN: APPLICATION DIVISION
SERIAL NO: 10/069,511 :
FILED: March 4, 2002 :
FOR: CERAMIC HEATER FOR
SEMICONDUCTOR PRODUCING/
EXAMINING DEVICE

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Prior to a first examination on the merits, please amend the above-identified
application as follows:

IN THE TITLE

Please delete the current title and insert therefor:

CERAMIC HEATER FOR SEMICONDUCTOR

MANUFACTURING/TESTING APPARATUS

al